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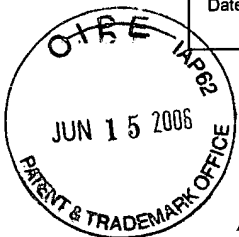
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: June 12, 2006

Signature:

(Thomas A. Miller)

Atty. Docket No. 28944/50023



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE AS
DESIGNATED/ELECTED OFFICE

Applicant: Philippe Cormont, et al.)	Title: Method and Device for Lithography by
)	Extreme Ultraviolet Radiation
Serial No.: 10/570,726)	
)	Group Art Unit: To be assigned
Intl. Appl. No.: PCT/FR2004/002226)	
)	Examiner: To be assigned
Intl Filing Date: 01 September 2004)	
)	Filed: March 6, 2006

SUPPLEMENTAL PRELIMINARY AMENDMENT

Mail Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Prior to examination, please amend the accompanying application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 11 of this paper.